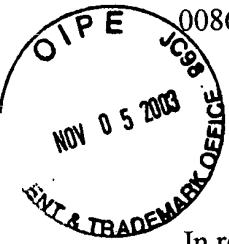


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PATENT APPLICATION

00862.022238



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shigeyuki UZAWA

Application No.: 09/865,454

Filed: May 29, 2001

For: EXPOSURE APPARATUS, DEVICE  
MANUFACTURING METHOD,  
SEMICONDUCTOR MANUFACTURING  
PLANT AND METHOD OF MAINTAINING  
EXPOSURE APPARATUS

)  
: Examiner: A. Stevenson  
)  
: Group Art Unit: 2812  
)  
: Confirmation No.: 3754  
)  
: Allowed: October 22, 2003  
)  
: November 5, 2003  
)  
:

**Mail Stop Issue Fee**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED NOTICE OF ALLOWANCE

Sir:

Applicant has received a Notice of Allowance and a Notice of Allowability dated October 22, 2003, in the above-identified application, in which the Notice of Allowance lists the TITLE OF INVENTION as "EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD, SEMICONDUCTOR MANUFACTURING PLANT AND METHOD MAINTAINING EXPOSURE APPARATUS."

The title omits the word "OF" after the word "MAINTAINING." Applicant, therefore, requests that the TITLE OF THE INVENTION be corrected to read -- EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD, SEMICONDUCTOR

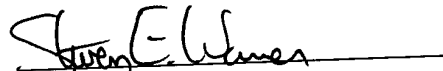
MANUFACTURING PLANT AND METHOD OF MAINTAINING EXPOSURE

APPARATUS --. Accordingly, Applicant requests that a corrected Notice of Allowance be issued to make this correction.

Applicant believes that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated therewith. A duplicate of this document is enclosed for this purpose.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our below-listed address.

Respectfully submitted,

  
Attorney for Applicant  
Steven E. Warner  
Registration No. 33,326

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SEW/eab